

501.22642CC0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): **FUJISAKI et al**

Serial No.:

Filed: **July 23, 2003**

For: **III-V Single Crystal As Well As Method Of
Producing The Same, And Semiconductor
Device Utilizing The III-V Single Crystal**

Art Unit:

Group:

REAFFIRMATION OF CLAIM FOR PRIORITY

Mail Stop: Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 23, 2003

Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants
hereby claim the right of priority based on Japanese Patent Application No.
208262/1984, filed in Japan on October 5, 1984.

The certified copy of the above-referred to Japanese Patent Application
was filed on May 19, 1988 in prior application Serial No. 783,365, filed
October 3, 1985.

Respectfully submitted,

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